IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

RUDOLF FLOSBACH

Docket No.: 327 084

Serial No.: Not Assigned

Filed: Concurrently Herewith

For:

FILM LEAK DETECTOR

Assistant Commissioner for Patents Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT **UNDER RULE 1.97**

Sir:

In accordance with the duty of disclosure under 37 CFR § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached Form PTO-1449 and/or listed herein and which the Examiner may deem relevant to patentability of the claims of the above-identified application.

One copy of each of the listed documents is submitted herewith.

The present Information Disclosure Statement is being filed (1) no later than three months from the application's filing date or (2) before the mailing date of the first Office Action on the merits (whichever is later), and therefore no certification under 37 CFR § 1.97(e) or fee under 37 CFR § 1.17(p) is required.

The submission of the listed documents is not intended as an admission that any such document constitutes prior art against the claims of the present application. Applicant does not waive any right to take any action that would be appropriate to antedate or otherwise remove any listed document as a competent reference against the claims of the present application.

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The Commissioner is hereby authorized to charge any additional fees associated with this communication or credit any overpayment to deposit Account No. 50-0289. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

WALL MARJAMA & BILINSKI

By:

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I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 addressed to the Box Patent Application,
Assistant Commissioner for Patents; Washington D.C. 20231 on

Patricia L. Pontello